Customer No.: 31561 Docket No.: 10573-US-PA

Application No.: 10/604,793

P. 07/09

REMARKS

Present Status of the Application

Claims 1, 3-7 are rejected under 35 U.S.C 112, second paragraph, as being indefinite for

failing to particularly point out and distinctly claim the subject matter which applicant regards as

the invention. The Office Action rejected claims 1, 6, 8-12 under 35 U.S.C. 103(a) as being

unpatentable over Tomita (U.S. 5,634,980) in view of Nonomura (US 5,601,645).

In addition, the office action stated claims 3-5 and 7 are allowable if rewritten to

overcome the rejections and include all of the limitations of the base claim and any intervening

claims.

Applicant has amended claims 1 and 7 and canceled claim 3 to more clearly define the

present invention. After entry of the foregoing amendments, claims 1, 4-12 remain pending in

the present application, and reconsideration of those claims is respectfully requested.

Rejections under 35 U.S.C 112, second paragraph

The office action rejected claims 1, 3-7 under 35 U.S.C 112, second paragraph, as being

indefinite for failing to particularly point out and distinctly claim the subject matter which

applicant regards as the invention. The office action stated in claim 1 "wafer carrier beams"

constitutes an indefinite subject matter because it is not clear what applicant regards as carrier

beam and the instant disclosure does not describe the carrier beam. Therefore, the structure

recited by claim 7 is not readily ascertainable.

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Applicant has amended "a plurality of wafer carrier beams for holding the wafer" in claim 1

to clearly define the wafer carrier beams are used to holding the wafer in the sampling chamber.

As a matter of fact, the description about the wafer carrier beams is at paragraph [0031] of the

specification. Therefore, applicant respectfully submits the instant disclosure has described the

wafer carrier beams.

In addition, applicant has amended a typographic error in claim 7 that is "wherein at least a

height of one of the wafer carrier beams is lower that than a height of the other wafer carrier

beams". The limitation recited in claim 7 is also described at paragraph [0031]. It is believed the

structure recited by claim 7 is readily ascertainable after the amendment is entered.

Allowable subject matter

The office action stated claims 3-5 and 7 are allowable if rewritten to overcome the

rejections and include all of the limitations of the base claim and any intervening claims.

Applicant has amended claim 1 with adding the limitation of claim 3 into claim 1. It is

believed the amended claim 1 should be allowed. In addition, since claim 1 is allowed, its

dependent claims 4-12 should also be allowed as a matter of law.

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## **CONCLUSION**

For at least the foregoing reasons, it is believed that the pending claims are in proper condition for allowance. If the Examiner believes that a telephone conference would expedite the examination of the above-identified patent application, the Examiner is invited to call the undersigned.

Date: April 1), 2007

Respectfully submitted,

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